



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Pelella et al.

Title: SEMICONDUCTOR

SUBSTRATE AND PROCESSES

THEREFOR

Appl. No.: 10/729,479

Filing Date: 12/05/2003

Examiner: David Nhu

Art Unit: 2818

CERTIFICATE OF EXPRESS MAILING
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(Pajated Name)

(Signature)

AMENDMENT UNDER 37 CFR 1.312

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Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant acknowledges receipt of a Notice of Allowance in the above-captioned application. Prior to payment of the issue fee, please amend the application as follows:

Amendment to the Title begins on page 2 of this document.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this document.

Remarks/Arguments begin on page 6 of this document.

Please amend the application as follows:

6/7²9 479 Atty. Dkt. No. 039153-0683 (H1721)

Amendments to the Title:

Enta

Please amend the Title as follows:

As previously amended on December 15, 2004, please replace the Title with the following rewritten Title:

STRAINED SEMICONDUCTOR SUBSTRATE AND PROCESSES THEREFOR